

AF 12829  
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Docket No.: 57454-279

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor Application of

Hiromitsu SUGIMOTO, et al.

Serial No.: 09/987,893

Filed: November 16, 2001

For: SUBSTRATE TESTING APPARATUS AND SUBSTRATE TESTING METHOD

: Customer Number: 20277

: Confirmation Number: 7560

: Group Art Unit: 2829

: Examiner: Nguyen, Tung X

**PETITION FOR EXTENSION OF TIME**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

TECHNOLOGY CENTER 2800

SEP 12 2003

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Sir:

It is respectfully requested that the time for response to the Office Action dated April 8, 2003, now due to expire July 8, 2003, be extended for two months and set to expire on September 8, 2003.

Please charge the extension fee of \$410.00 to Deposit Account No. 500417. Please charge any additional fees or credit any overpayment to Deposit Account No. 500417.

Respectfully submitted,

09/09/2003 HDANTE1 00000137 500417 09987893

02 FC:1252 410.00 DA

MCDERMOTT, WILL & EMERY

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**Date: September 8, 2003**